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9/5/03

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HIROYOSHI TANIMOTO, ET AL. : EXAMINER: PERKINS, P. E.
SERIAL NO: 10/001,977 :
FILED: DECEMBER 5, 2001 : GROUP ART UNIT: 2822
FOR: SEMICONDUCTOR DEVICE, :
METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE, AND
SYSTEM FOR EVALUATING
ELECTRICAL CHARACTERISTICS OF
SEMICONDUCTOR DEVICE

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated February 26, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.

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AUG 29 2003
TECHNOLOGY CENTER 2800